

Notice of References Cited	Application/Control No. 10/802,285		Applicant(s)/Patent Under Reexamination RAVEENDRAN ET AL.	
	Examiner DAVID P. RASHID		Art Unit 2624	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,240,135	05-2001	Kim, Hyun Mun	375/240.01
*	B	US-5,107,345	04-1992	Lee, Chong U.	382/250
*	C	US-5,452,104	09-1995	Lee, Chong U.	358/426.14
*	D	US-5,748,792	05-1998	Wober, Munib A.	382/250
*	E	US-5,903,669	05-1999	Hirabayashi, Yasuji	382/232
*	F	US-5,982,441	11-1999	Hurd et al.	348/417.1
*	G	US-6,031,937	02-2000	Graffagnino, Peter N.	382/236
*	H	US-6,526,174	02-2003	Graffagnino, Peter N.	382/236
*	I	US-6,529,634	03-2003	Thyagarajan et al.	382/239
*	J	US-2003/0156648	08-2003	Holcomb et al.	375/240.18
*	K	US-2003/0202608	10-2003	MacInnis et al.	375/240.29
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.